



Surface Sensitive X-ray Scattering



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Introduction

- Concepts of surfaces
- Scattering (Born approximation)

Crystal Truncation Rods

- The basic idea
- How to calculate
- Examples

Reflectivity

- In Born approximation
- Exact formalism (Fresnel)
- Examples

Grazing Incidence Diffraction

- The basic idea
- Penetration depth
- Example

Diffuse Scattering

- Concepts of rough surfaces
- Correlation functions
- Scattering Born-approximation
- DWBA
- Examples

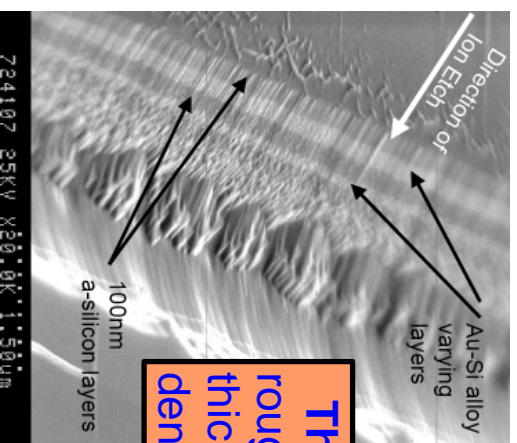
With **x-ray and neutron reflectivity** **surfaces, buried interfaces and** **the properties of thin film systems** can be investigated on a **micro- and nanoscale**.

Fundamental science, e.g.:

- layer growth
- roughness evolution

Industrial applications, e.g.:

- semiconductor devices
- storage devices / harddisks
- coatings
- lubricants
- catalysts



The layers' roughnesses ? thicknesses ? densities ?

Advantages of x-ray and neutron reflectometry:

- Resolution in the **Å-regime**
- Gives a **lot of information** with just one measurement
- Usually **non-destructive**
- Highly **element specific**
- **No special preparation** of the sample
- **(Averaged information over whole sample area)**

Disadvantages of x-ray and neutron reflectometry:

- **No unique results** without preknowledge
- **No fast results**
- **Interpretation/analysis often not easy**
- **(No local information)**

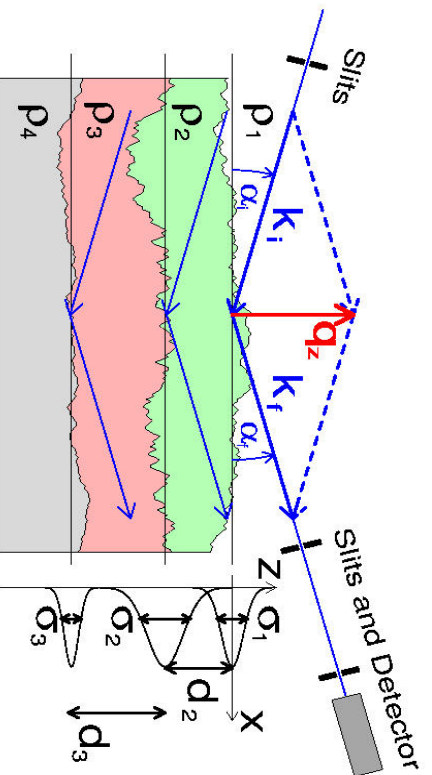
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Theoretical Part

a) General Considerations

Photons with wavelength λ (or neutrons with $\lambda = h/\sqrt{2mE}$) are scattered **elastically** (no energy change: $\lambda_i = \lambda_f$) at the surface.

The incident angle α_i equals the exit angle α_f .

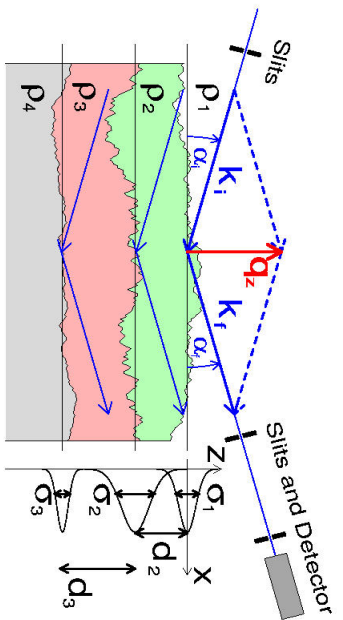


The density ρ_j means:

- **Electron density** for x-rays
- **Scattering length density** for neutrons

Wave vector transfer
$$q_z = \frac{4\pi}{\lambda} \sin(\alpha_f) = 2k_0 \sin(\alpha_f)$$

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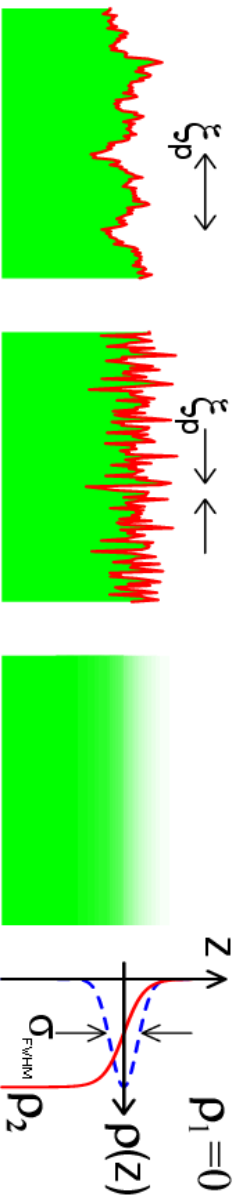


q_z is perpendicular to the surface



only sensitive to information perpendicular to the surface :
 electron (scattering length) density profile $\langle \rho(x,y,z) \rangle_{(x,y)} = \rho(z)$.

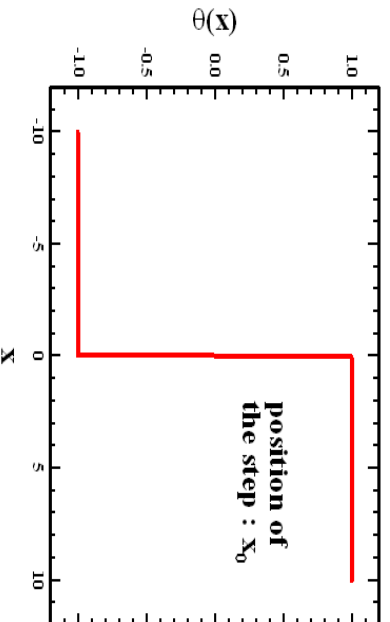
That means: a reflectivity cannot distinguish different in-plane structures.



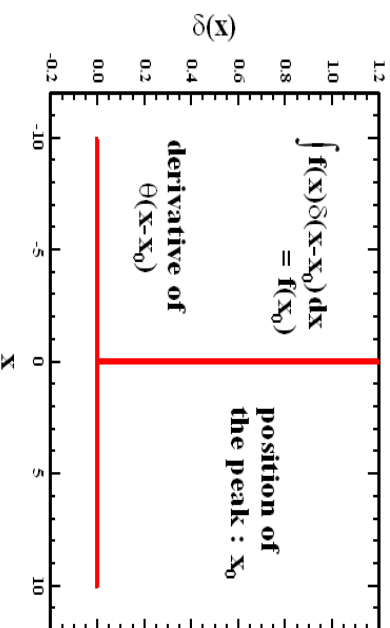
These different surfaces have the same reflectivity !

The following functions are important in the following:

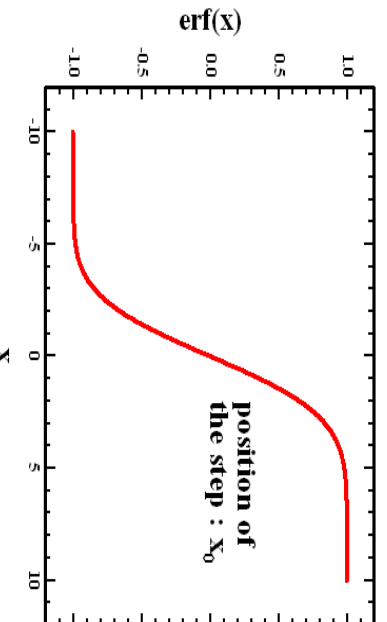
step function $\theta(x-x_0)$



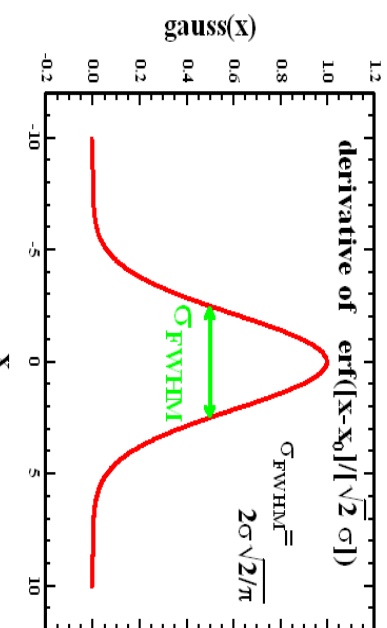
delta function $\delta(x-x_0)$



error function $\text{erf}([x-x_0]/[\sqrt{2} \sigma])$



Gaussian $\exp(-[(x-x_0)/\sigma]^2/2)$



Specularly Reflected Intensity in

Born Approximation ($I_{scat} \ll I_0$)

$$I(q_z) \propto \frac{1}{q_z^4} \left| \int \frac{d\rho(z)}{dz} \exp(iq_z z) dz \right|^2$$

Given by the **absolute square** of the **Fourier transformation** of the **derivative** of the **density/(scattering length) profile** and divided by q_z^4 .

Consequences:

- Reflected intensity **drops fast** with increasing angle : $1/q_z^4$
- Only differences in density can be seen (**contrast**) : **Derivative**
- Only sensitive to density properties in **z-direction** : **Density profile**
- **No direct picture** visible : **Fourier space**
- Phase information gets lost \Rightarrow **no unique solution** : **Absolute square**

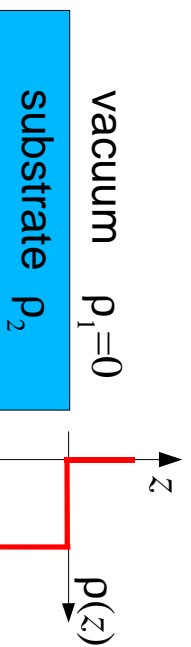


Surface Sensitive X-ray Scattering



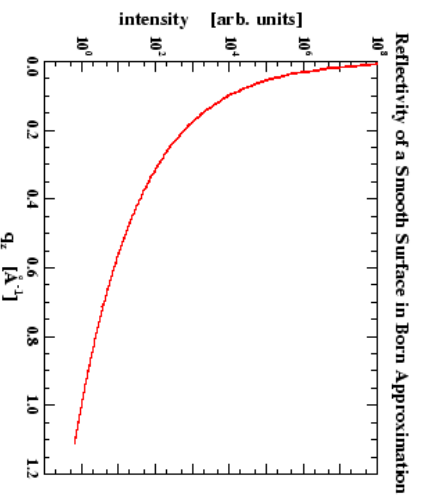
Examples

1) single smooth surface
at $z = 0$



Density profile: $\rho(z) = \frac{\rho_2}{2} (1 - \Theta[z]) \Rightarrow \frac{d\rho}{dz} \propto \delta(z)$

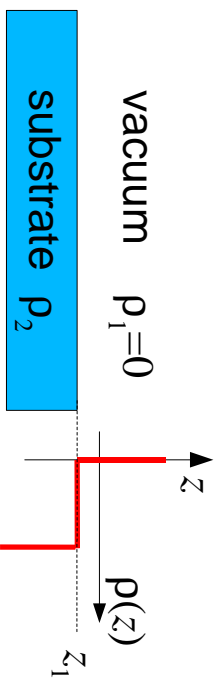
$$\begin{aligned} I(q_z) &\propto \frac{1}{q_z^4} \left| \int \frac{d\rho(z)}{dz} \exp(iq_z z) dz \right|^2 \\ &= \frac{1}{q_z^4} \left| \int \delta(z) \exp(iq_z z) dz \right|^2 \\ &= \frac{1}{q_z^4} |\exp(iq_z \cdot 0)|^2 = \frac{1}{q_z^4} \cdot |1|^2 = \frac{1}{q_z^4} \end{aligned}$$



Surface Sensitive X-ray Scattering



2) single smooth surface at $z = z_1$ (shifted)



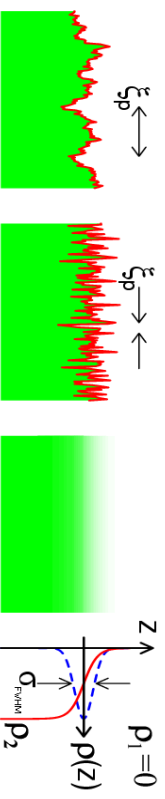
Density profile: $\rho(z) = \frac{\rho_2}{2} (1 - \Theta[z - z_1]) \Rightarrow \frac{d\rho}{dz} \propto \delta(z - z_1)$

$$I(q_z) \propto \frac{1}{q_z^4} \left| \int \frac{d\rho(z)}{dz} \exp(iq_z z) dz \right|^2 = \frac{1}{q_z^4} \left| \int \delta(z - z_1) \exp(iq_z z) dz \right|^2$$

$$= \frac{1}{q_z^4} \left| \exp(iq_z z_1) \right|^2 = \frac{1}{q_z^4} \cdot 1^2 = \frac{1}{q_z^4}$$

A shift of the sample does not change the reflectivity.

3) single rough surface with roughness σ



Density profile: $\rho(z) = \frac{\rho_2}{2} \left[1 - \text{erf} \left(\frac{z}{\sqrt{2}\sigma} \right) \right] \Rightarrow \frac{d\rho}{dz} \propto \exp \left(\frac{-z^2}{2\sigma^2} \right)$

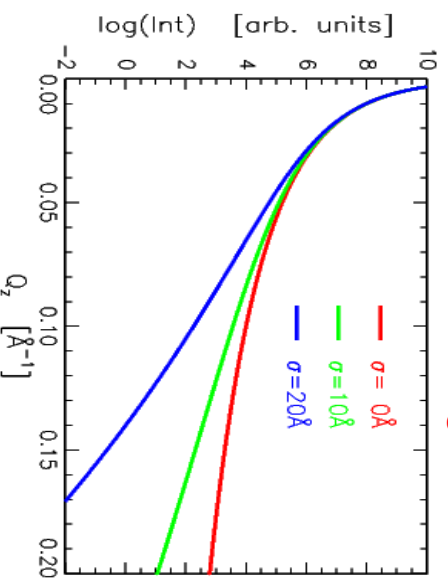
$$I(q_z) \propto \frac{1}{q_z^4} \left| \int \frac{d\rho(z)}{dz} \exp(iq_z z) dz \right|^2$$

$$= \frac{1}{q_z^4} \left| \int \exp \left(\frac{-z^2}{2\sigma^2} \right) \exp(iq_z z) dz \right|^2$$

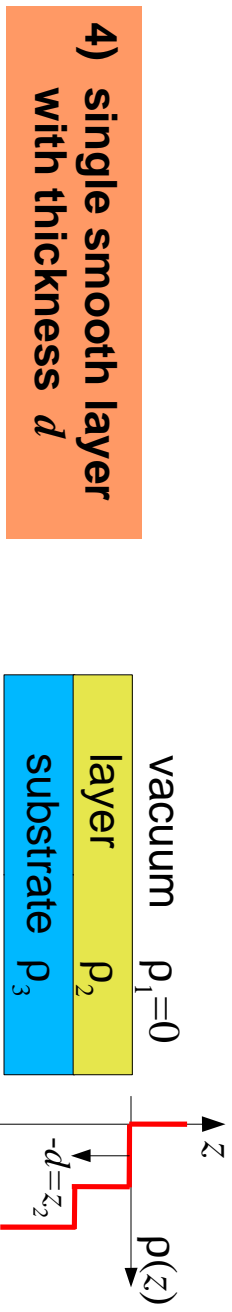
Fourier transformation is known!

$$\propto \frac{1}{q_z^4} \left| \exp \left(\frac{-q_z^2 \sigma^2}{2} \right) \right|^2 = \frac{1}{q_z^4} \exp(-q_z^2 \sigma^2)$$

Effect of the roughness



Debye-Waller factor



Density profile: $\rho(z) = -\frac{\Delta\rho_1}{2} [1 - \Theta(z)] + \frac{\Delta\rho_2}{2} [1 - \Theta(z+d)]$

Derivative of $\rho(z)$: $\frac{d\rho}{dz} \propto \Delta\rho_1 \delta(z) + \Delta\rho_2 \cdot \delta(z+d)$ with: $\Delta\rho_1 = \rho_2 - \rho_1$
 $\Delta\rho_2 = \rho_3 - \rho_2$

$$I(q_z) \propto \frac{1}{q_z^4} \left| \int \frac{d\rho(z)}{dz} \exp(iq_z z) dz \right|^2 = \frac{1}{q_z^4} \left| \int [\Delta\rho_1 \delta(z) + \Delta\rho_2 \delta(z+d)] \exp(iq_z z) dz \right|^2$$

$$= \frac{1}{q_z^4} |\Delta\rho_1 + \Delta\rho_2 \exp(-iq_z d)|^2 = \frac{1}{q_z^4} [\Delta\rho_1 + \Delta\rho_2 \exp(iq_z d)] \cdot [\Delta\rho_1 + \Delta\rho_2 \exp(-iq_z d)]$$

$$= \frac{1}{q_z^4} (\Delta\rho_1^2 + \Delta\rho_2^2 + \Delta\rho_1 \Delta\rho_2 [\exp(iq_z d) + \exp(-iq_z d)])$$

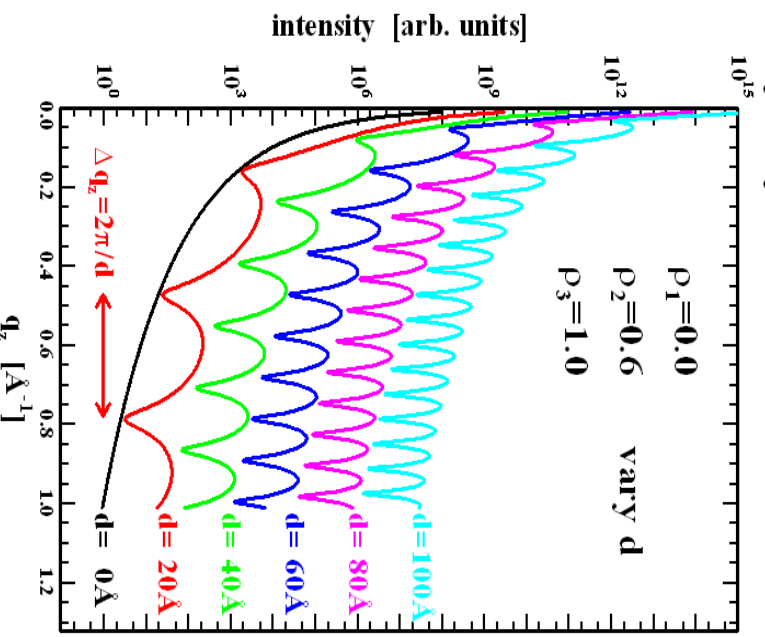
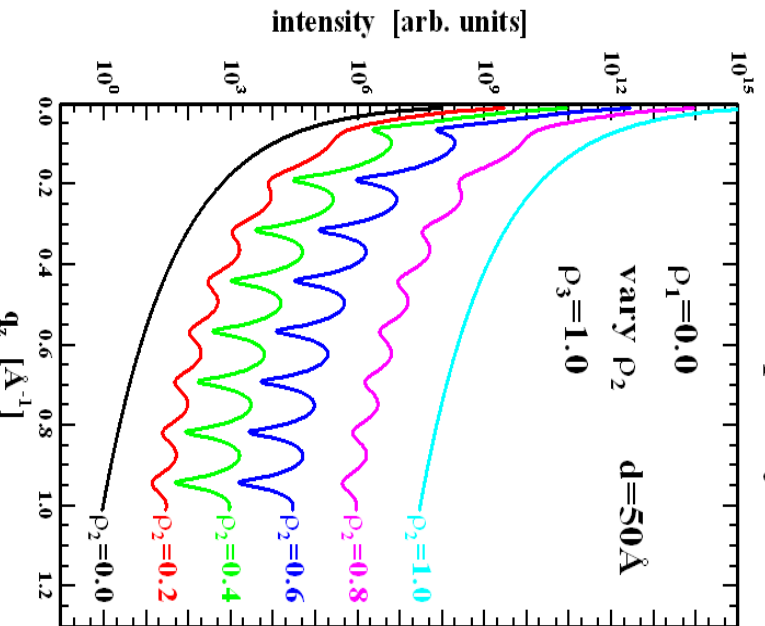
$$= \frac{1}{q_z^4} [\Delta\rho_1^2 + \Delta\rho_2^2 + 2\Delta\rho_1 \Delta\rho_2 \cos(q_z d)]$$

oscillating function

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- Contrasts $\Delta\rho_1$ and $\Delta\rho_2$ determine the visibility of the oscillations.
- Film thickness d determines the period via $\Delta q_z = 2\pi/d$.

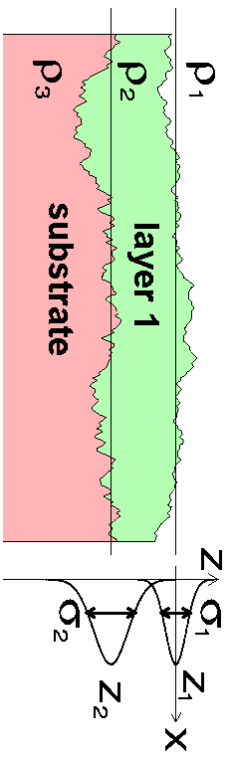
completely smooth one-layer system



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5) single layer with rough interfaces and thickness

$$d = -z_2$$



Density profile:

$$\rho(z) = \frac{\Delta\rho_1}{2} \left[1 - \operatorname{erf} \left(\frac{z - z_1}{\sqrt{2}\sigma_1} \right) \right] + \frac{\Delta\rho_2}{2} \left[1 - \operatorname{erf} \left(\frac{z - z_2}{\sqrt{2}\sigma_2} \right) \right]$$

Derivative of $\rho(z)$:

$$\frac{d\rho}{dz} \propto \frac{\Delta\rho_1}{\sigma_1} \exp \left(-\frac{(z - z_1)^2}{2\sigma_1^2} \right) + \frac{\Delta\rho_2}{\sigma_2} \exp \left(-\frac{(z - z_2)^2}{2\sigma_2^2} \right)$$

using :

$$\int \exp \left(-\frac{(z - z_1)^2}{2\sigma_1^2} \right) \exp(iq_z z) dz = \exp(iq_z z_1) \sqrt{2}\sigma_1 \exp \left(\frac{q_z^2 \sigma_1^2}{2} \right)$$

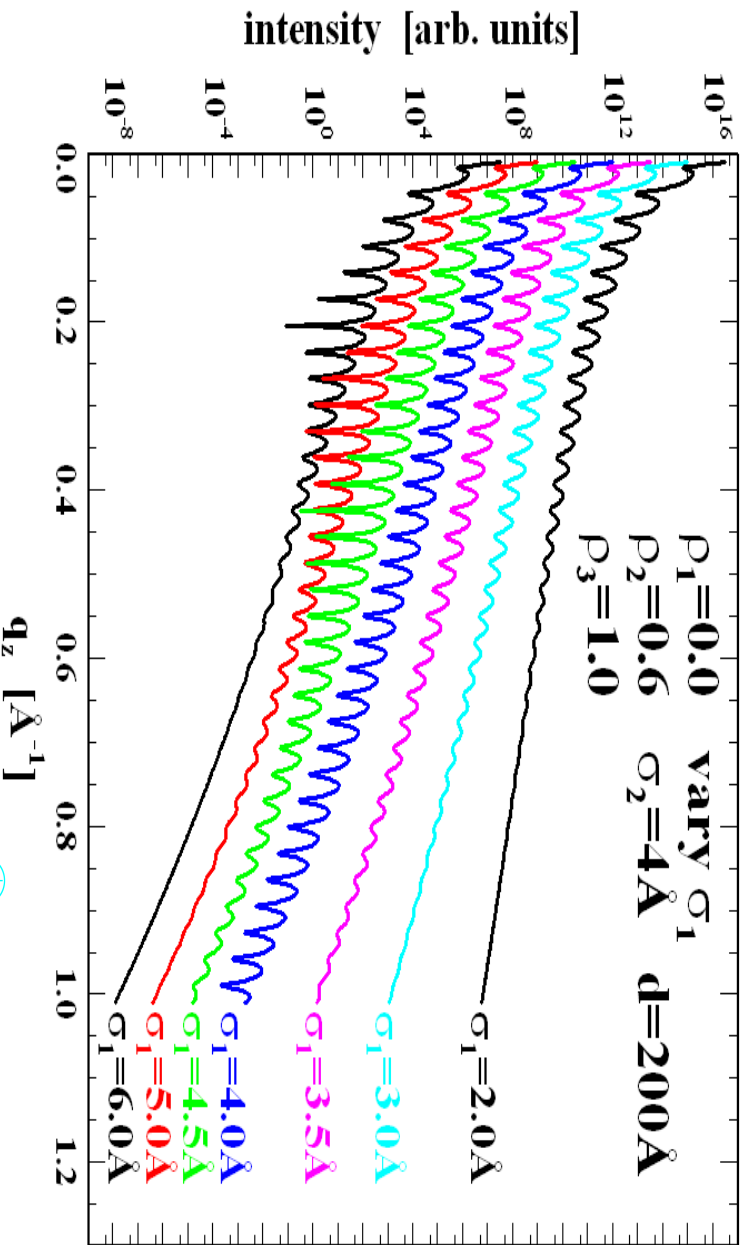
Result :

$$I(q_z) \propto \frac{1}{q_z^4} \left[\Delta\rho_1^2 \exp(-q_z^2 \sigma_1^2) + \Delta\rho_2^2 \exp(-q_z^2 \sigma_2^2) + 2\Delta\rho_1 \Delta\rho_2 \exp \left(-q_z^2 \frac{\sigma_1^2 + \sigma_2^2}{2} \right) \cos(q_z z_2) \right]$$

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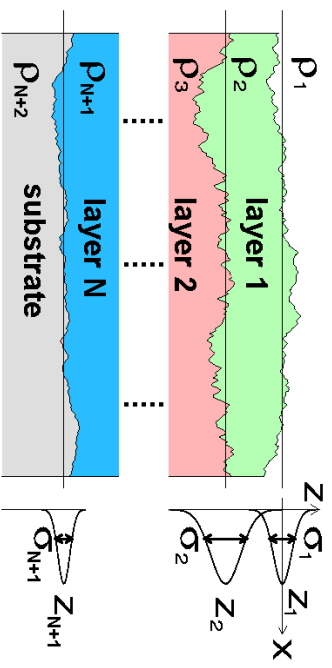
- At large q_z the scattering is dominated by the smoothest interface.
- The difference between the σ 's of a layer determines the “die-out” of the oscillations.

one layer system with rough interfaces



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5) general case: N rough layers



Density profile:

$$\rho(z) = \frac{1}{2} \sum_{j=1}^{N+1} \Delta \rho_j \left(1 - \operatorname{erf} \left[\frac{z - z_j}{\sqrt{2} \sigma_j} \right] \right) \quad \text{with} \quad \Delta \rho_j = \rho_{j+1} - \rho_j$$

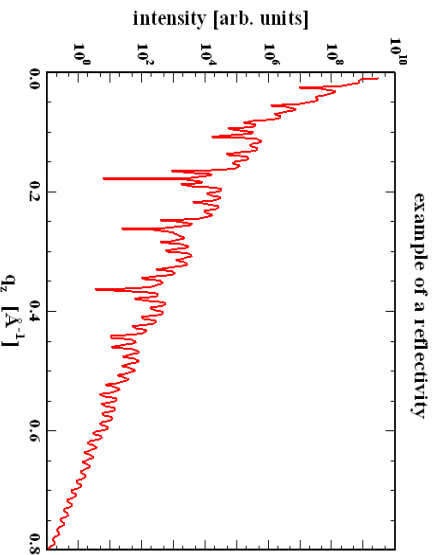
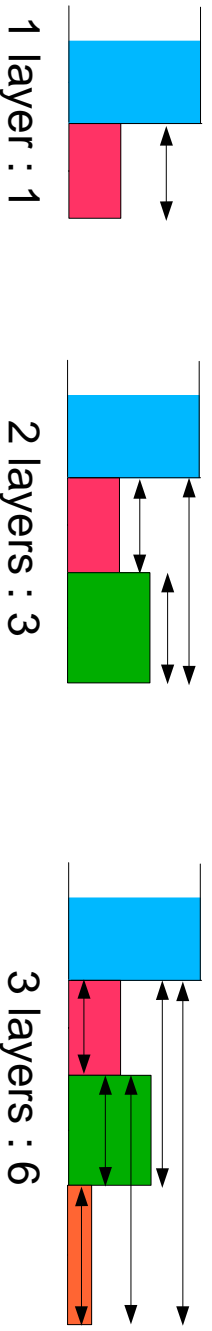
Scattering terms from the single interfaces

$$I(q_z) \propto \frac{1}{q_z^4} \left(\sum_{j=1}^{N+1} \Delta \rho_j^2 \exp(-q_z^2 \sigma_j^2) + 2 \sum_{j=1}^N \sum_{k=j+1}^{N+1} \Delta \rho_j \Delta \rho_k \exp\left(-q_z^2 \frac{\sigma_j^2 + \sigma_k^2}{2}\right) \cos[q_z(z_j - z_k)] \right)$$

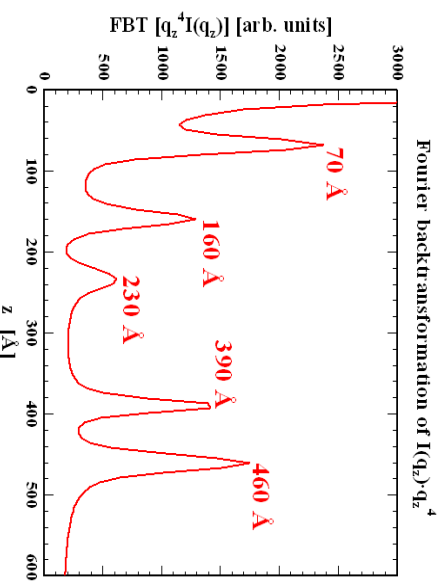
Each distance $z_j - z_k$ gives an oscillating term, scaled with the respective Debye-Waller factor and the contrasts at the interfaces.

For a first guess on reflectivity data: Fourier backtransformation of $q_z^4 \cdot I(q_z)$ will show distinct peaks for each oscillation (\Leftrightarrow distance).

Maximum number of distances



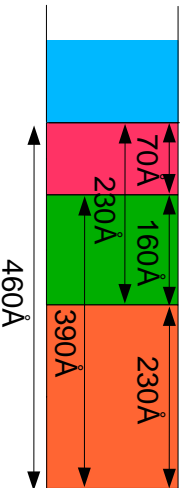
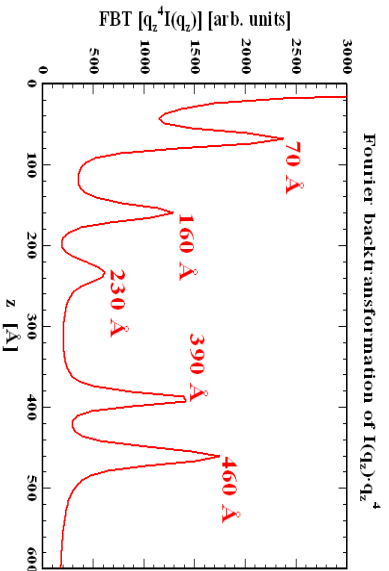
FTB \rightarrow



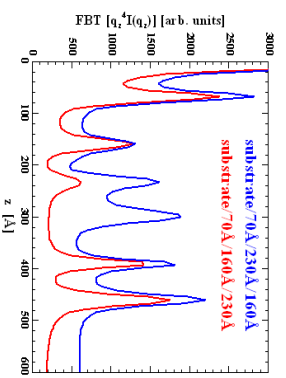
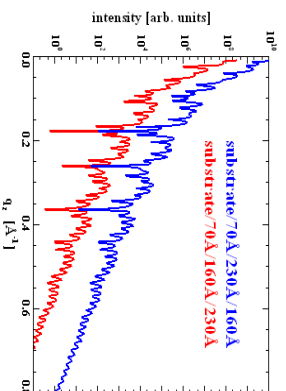
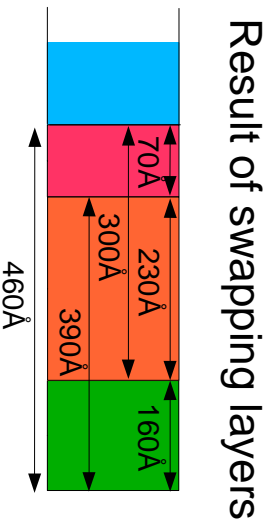
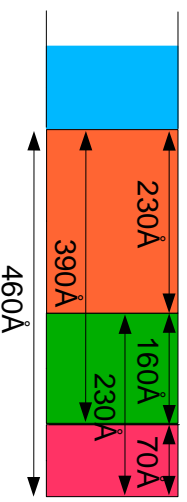
Only 5 peaks !

Likely a 3-layer system with one layer thickness matching the sum of two neighboring layers.

Two possibilities:



or



c) The Exact Fresnel Formalism (Optical Treatment)

Born approximation diverges for $q_z \rightarrow 0 \Rightarrow$

The **reflected intensity** cannot be larger than the **incident intensity**.
Multiple scattering for small angles have to be taken into account.

Starting point: Helmholtz equation
(remember: neutrons can be treated as waves)

$$\nabla^2 \mathbf{E}(\mathbf{r}) + k_0^2 n^2(\mathbf{r}) \mathbf{E}(\mathbf{r}) = 0$$

\mathbf{r} : vector in space

\mathbf{E} : electrical field for photons / wave function for neutrons

$k_0 = 2\pi/\lambda$: modulus of the wave vector

n : refractive index **for reflectivity** : $n(\mathbf{r}) = n(z)$

Electron density (for x-rays) or **scattering length density** (neutrons) translates to the **refractive index** :

$$n(z) = 1 - \delta(z) + i\beta(z)$$

with the **dispersion** δ and the **absorption** β .

X-rays:

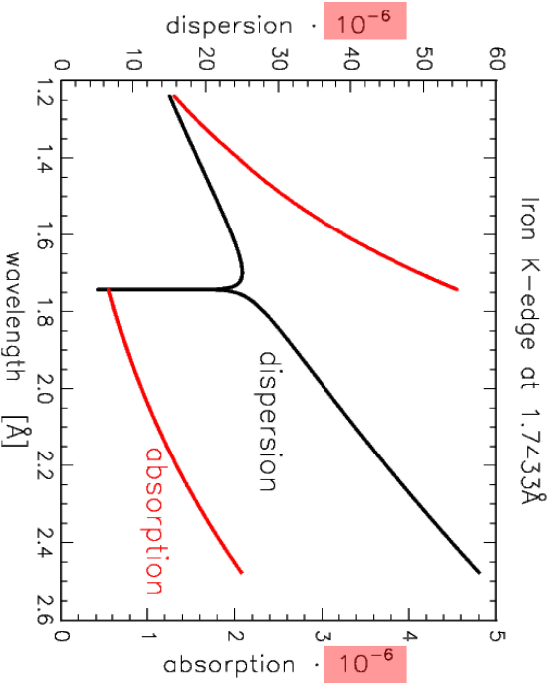
$$\delta(z) = \frac{\lambda^2}{2\pi} r_e \rho(z) \frac{f_0(q_z) + f_{sr}(\lambda)}{Z}$$

$$\beta(z) = \frac{\lambda^2}{2\pi} r_e \rho(z) \frac{f_{\gamma}(\lambda)}{Z}$$

r_e : classical e⁻ radius ρ : e⁻ density

Z : number of e⁻ f_0 : formfactor

$f_{sr} + if_{\gamma}$: corrections to formfactor



Neutrons:

$$\delta(z) = \frac{\lambda^2}{2\pi} N(z) b$$

β is usually negligible

N : particle density

b : scattering length

Mean value of the refractive index:

⇒ **total external reflection**

⇒ **critical angle** α_c

$$n < 1$$

$$\alpha_c \approx \sqrt{2\delta}$$

Fresnel reflection coefficient for a single smooth surface:

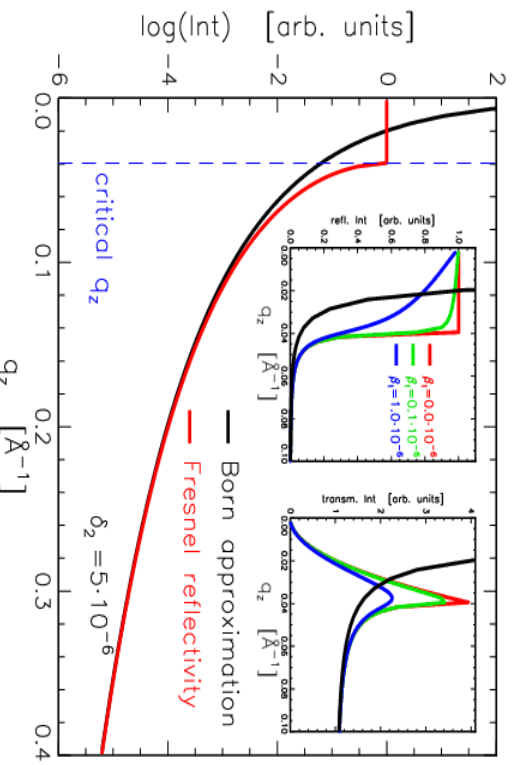
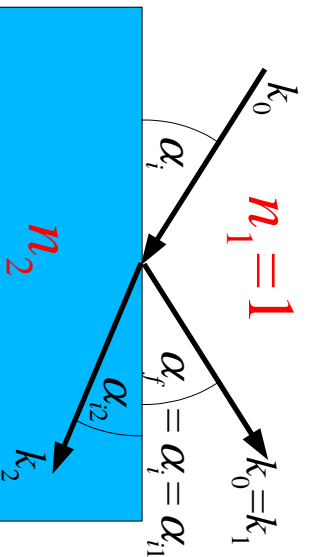
$$r_{1,2} = \frac{k_{z1} - k_{z2}}{k_{z1} + k_{z2}}$$

with

$$k_{z1} = k_1 \sin \alpha_{i1} = k_0 \sin \alpha_i = q_z / 2$$

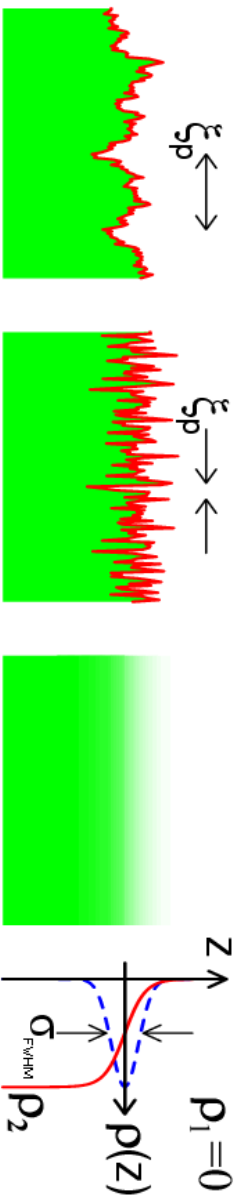
$$k_{z2} = k_2 \sin \alpha_{i2} = k_0 \sqrt{n_2^2 - \cos^2 \alpha_i}$$

$$I(\alpha_i) = |r_{1,2}|^2$$



If a surface is **rough**, the Fresnel reflection coefficient can be modified.

The result depends on the **exact probability function of the interface.**



Solids : **Error-function profile** \Rightarrow **Gaussian probability function**

Polymers : **tanh-function profile** \Rightarrow **$1/\cosh^2$ probability function**

$$\tilde{r}_{1,2} = r_{1,2} \exp(-2k_{z1} k_{z2} \sigma^2) \quad \text{Gaussian}$$

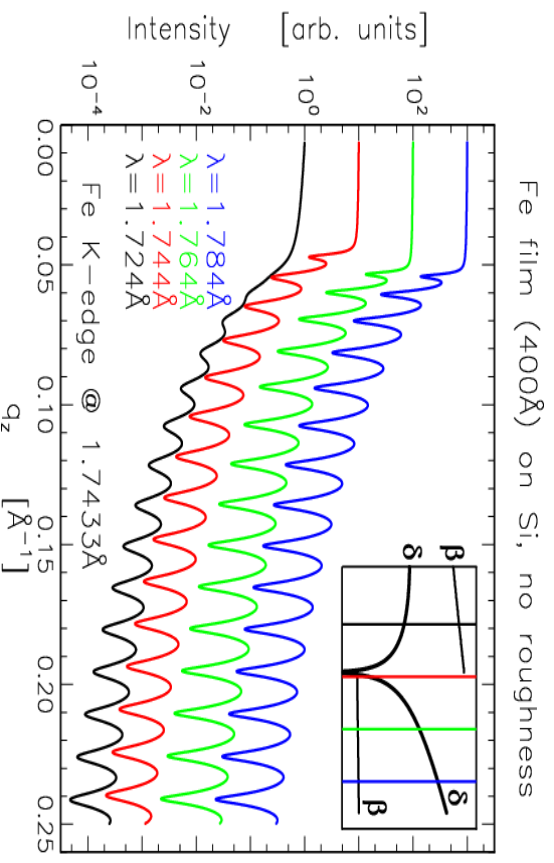
$$\tilde{r}_{1,2} = \frac{\sinh[\sqrt{3}\sigma(k_{z1} - k_{z2})]}{\sinh[\sqrt{3}\sigma(k_{z1} + k_{z2})]} \quad 1/\cosh^2$$

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Smooth layer systems (recursive formalism by Parratt)

for each interface j : $r_{j,j+1} = \frac{k_{z,j} - k_{z,j+1}}{k_{z,j} + k_{z,j+1}}$ $k_{z,j} = k_0 \sqrt{n_j^2 - \cos^2 \alpha_i}$

Recursion:
starting with $X_{N+1} = 0$
(N : number of layers)
end of recursion:
 $|X_1|^2 = I(q_z)$



$$X_j = \exp(-2ik_{z,j} z_j) \frac{r_{j,j+1} + X_{j+1} \exp(2ik_{z,j+1} z_j)}{1 + r_{j,j+1} X_{j+1} \exp(2ik_{z,j+1} z_j)}$$

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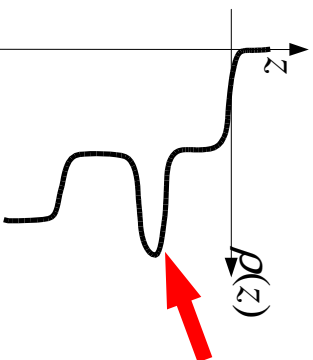
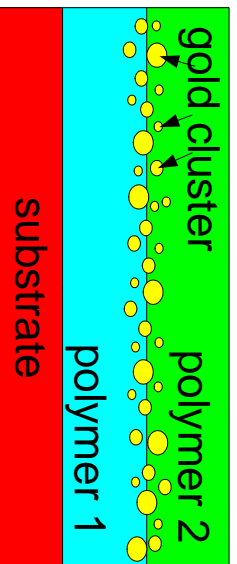
For **rough layer** systems the $r_{j,j+1}$ can be **replaced** by the $\tilde{r}_{j,j+1}$

$$\tilde{X}_j = \exp(-2ik_z z_j) \frac{\tilde{r}_{j,j+1} + X_{j+1} \exp(2ik_z z_{j+1})}{1 + \tilde{r}_{j,j+1} X_{j+1} \exp(2ik_z z_{j+1})}$$

However, this is only an approximation.

It fails for thin layers with large roughness.

e.g.



This layer can be described by a standard thin film model but the Parratt formalism may fail.

There is a way to get around this problem (see later).

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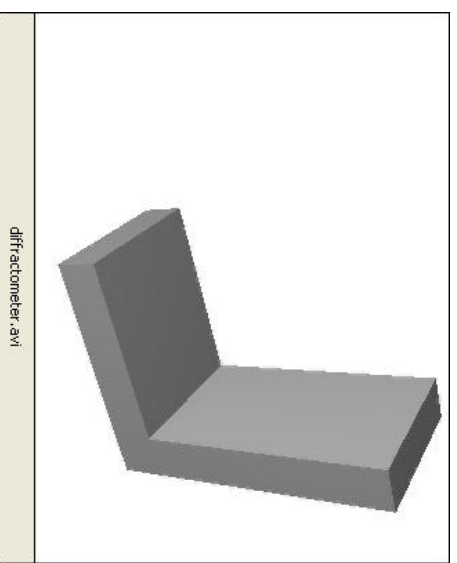


Experimental part

1) The diffractometer

Has many **degrees of freedom** with high accuracy (0.001° angular resolution / 0.01mm translational resolution).

Many **slits** are necessary to **define the beam direction** (not discussed here).



Degrees of freedom

- 2θ : Detector rotation
- ω : Sample rotation (incident angle)
- χ : 1. Euler angle (align surface parallel)
- ϕ : 2. Euler angle (not used for reflectivity)
- y : Sample movement up↔down
- x : Sample movement along the beam
- z : Sample movement horizontally
- $g\gamma$: Goniometer movement up↔down

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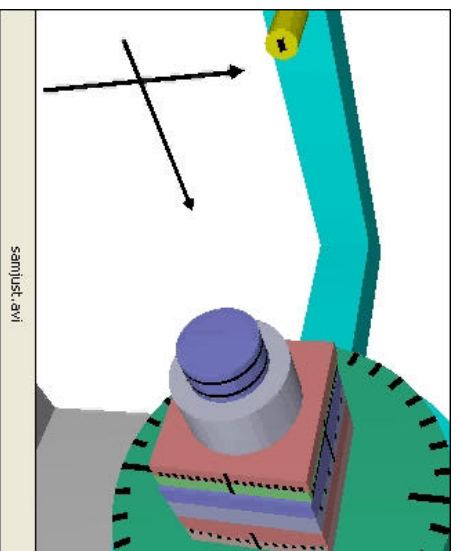
Surface Sensitive X-ray Scattering



2) Alignment of the sample

Goal

Put the center of the sample surface to center of rotation (marked by the beam after centering the diffractometer).



Procedure

- 1) Scan the primary beam without the sample. Note the intensity I_0 and the width σ and go with 2θ to the maximum. Calibrate this to 0.
- 2) Scan the sample in y -direction. Move y so that the sample cuts half of the beam.
- 3) Scan ω . Find the maximum, go there and calibrate to 0.
- 4) Redo step 2).
- 5) The ω -scan may not look symmetric. Move the sample in x -direction until it is.
- 6) Go to some $\omega=2\theta$ value (e.g. $\omega=1^\circ$, $2\theta=2^\circ$), scan ω and go to the maximum. Calibrate this as $2\theta/2$. This is much more accurate than step 3).
- 7) If the width of 6) is **not** $\sigma/2$ the sample is bent and has to be cut in smaller pieces!
- 8) Scan χ widely and go to the maximum to make the surface parallel to the beam.

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Surface Sensitive X-ray Scattering



Techniques for refinement

1) Standard technique

- Take the data and have a qualitative look at it.
- Parametrize a density profile by film thickness, averaged film densities and interface roughnesses which may match the data. So create a model of the system.
- Take into account all external parameters (resolution of the diffractometer, background, size of the beam, size of the sample) and include them into the model.
- Take a reasonable assumption on the parameters which may match the sample conditions best (preknowledge) and calculate a reflectivity using the Parratt formalism with modified Fresnel reflection coefficients.
- Optimize χ^2 under the constraint of physical reasonability.

$$\chi^2 = \sum_{j=1}^M (I_{j, \text{Data}}(q_z) - I_{j, \text{Model}}(q_z))^2$$

with M data points

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Surface Sensitive X-ray Scattering

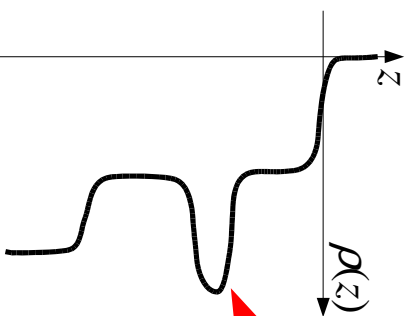
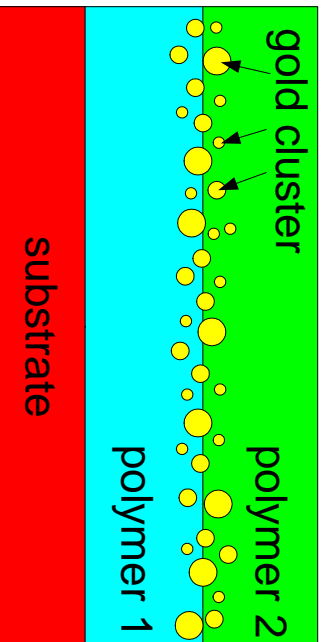


2) Effective density model

The standard technique usually works well. It **fails** if the system contains **thin layers with roughnesses equal or larger than the film thickness** (incomplete layers).

Reason: Interfaces cannot be treated separately any more.

Example: Thin (30Å) gold layers embedded in polymer matrices



This layer can be described by a standard thin film model but the Parratt may fail.

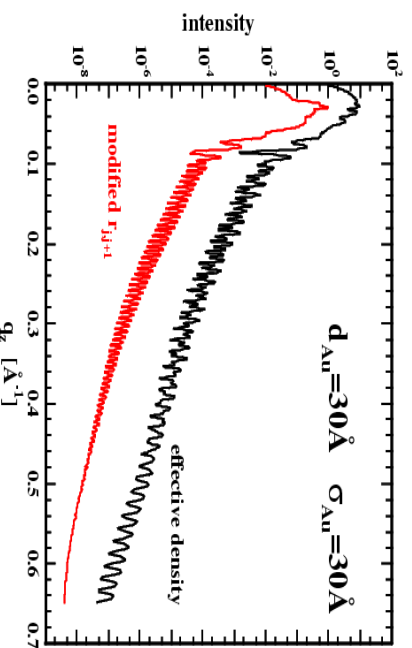
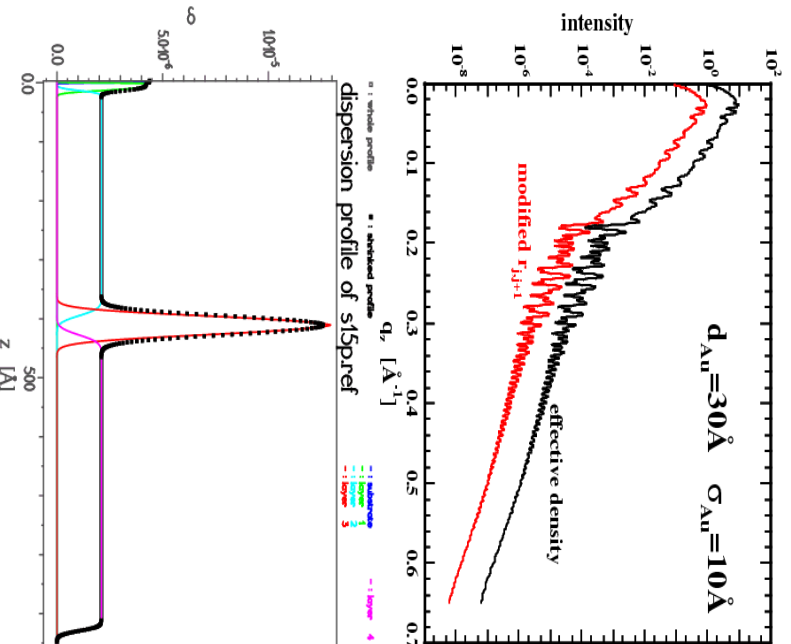
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Surface Sensitive X-ray Scattering



- Reflectivity can be calculated by the effective density model.
- 1) calculating the whole density profile first
 - 2) slicing into many very thin completely smooth sublayers
 - 3) using this slicing for the iterative Parratt algorithm (slow!)



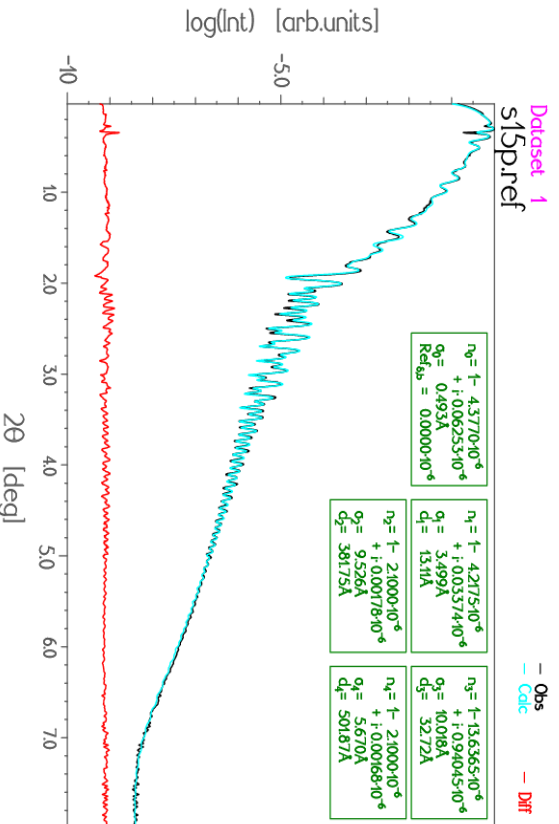
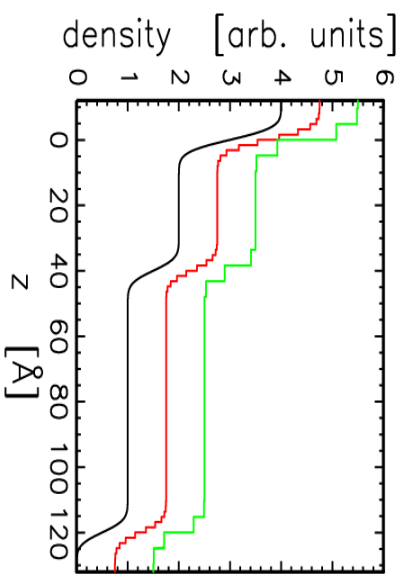
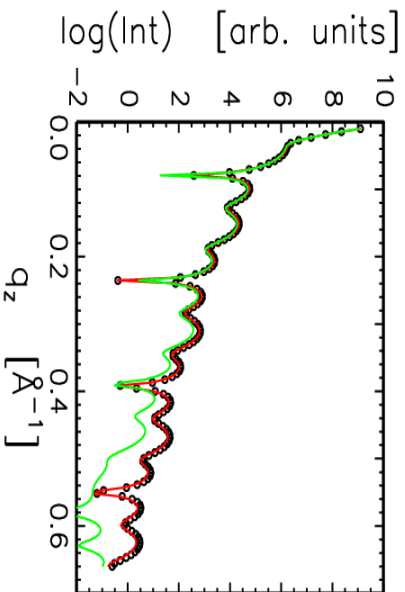
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Surface Sensitive X-ray Scattering



The slicing has to be **adapted** to the q_z -range which has been covered.



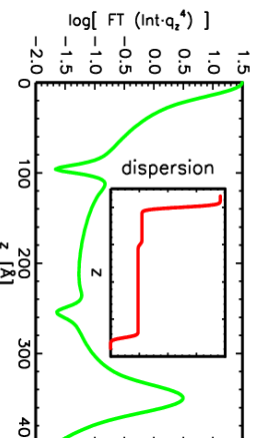
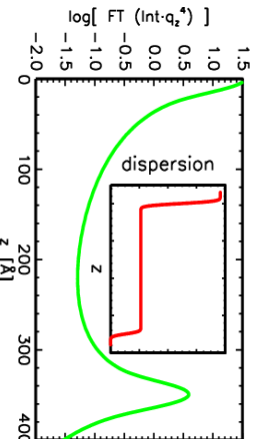
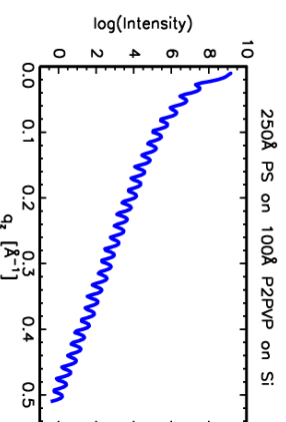
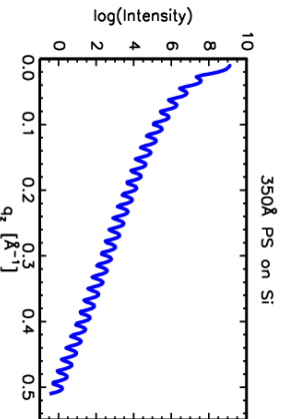
Data and fit of a Si-PSSA(15%)-Au-PS thin film system (effective density model)
red curve is the difference

3) The Fourier method

To **increase** the sensitivity to **low contrast** interfaces: Include the Fourier backtransformation of $I(q_z)$ (Patterson function $P(z)$) to the refinement.

$$P(z) = \left| \int_{q_z, low}^{\infty} q_z^4 I(q_z) \cos(q_z z) dq_z \right|^2$$

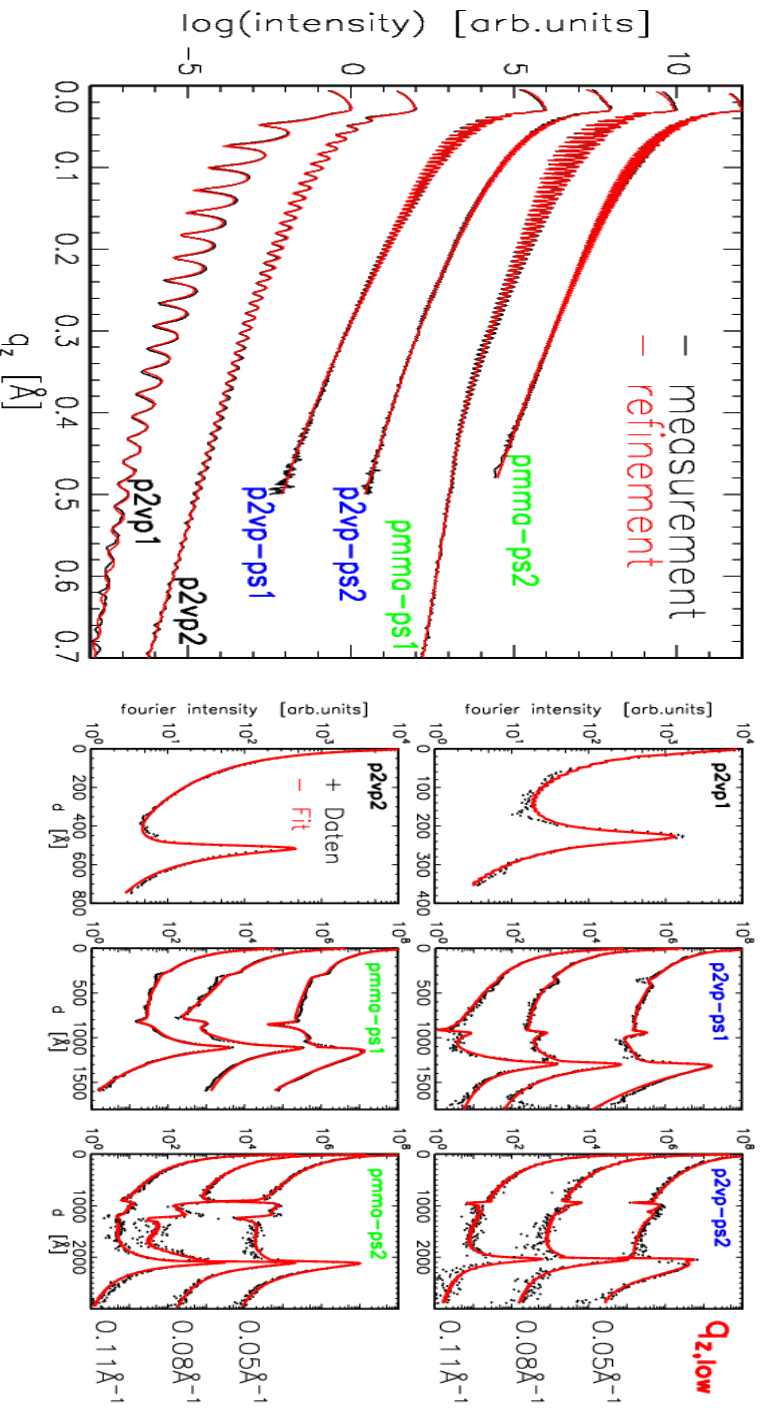
$$\Rightarrow I(q_z) \propto \frac{1}{q_z^4} \left| \int \frac{d\rho(z)}{dz} \exp(iq_z z) dz \right|^2$$



Position of the peaks/dips
 \Rightarrow **Layer thickness**
 \Rightarrow **Shape+intensity**
 \Rightarrow **Probability function of the interface**

Polymer Mono- and Bilayers @ 11keV

$$\delta_{\text{SI}}=4.03 \cdot 10^{-6} \quad / \quad \delta_{\text{PS}}=1.92 \cdot 10^{-6} \quad / \quad \delta_{\text{P2VP}}=2.00 \cdot 10^{-6} \quad / \quad \delta_{\text{PMMA}}=2.17 \cdot 10^{-6}$$



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Summary

- X-ray or neutron reflectometry is a very helpful tool to investigate thin layer systems.
- The reflectivity is basically sensitive to the density profile perpendicular to the sample surface.

$$I(q_z) \propto \frac{1}{q_z^4} \left| \int \frac{d\rho}{dz} \exp(iq_z z) dz \right|^2$$

- Special care has to be taken when aligning the samples on a diffractometer.
- To successfully analyze the data often special tricks have to be applied.

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